

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Express Mail Number EV342470635US

Docket Number (Optional)

100-23700 (P05749)

Application Number

New

Applicant(s)

Peter J. Hopper et al.

Filing Date

Herewith

Group Art Unit

Unknown

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<u>DL</u>		U.S. Appln. 10/290,138		Padmanabhan et al.			11/06/02
		6,440,801 B1	08/27/02	Furukawa et al.	438	272	06/28/00
		5,578,850	11/26/96	Fitch et al.	257	329	01/16/96
		4,871,684	10/03/89	Glang et al.	437	31	10/29/87
		6,504,210 B1	01/07/03	Divakaruni et al.	257	344	06/23/00
		5,963,800	10/05/99	Augusto	438	212	06/17/96
		5,170,243	12/08/92	Dhong et al.	365	208	11/04/91
		6,337,497 B1	01/08/02	Hanafi et al.	257	306	05/16/97
		6,204,532 B1	03/20/01	Gambino et al.	257	329	10/05/99
		5,627,395	05/06/97	Witek et al.	257	350	11/02/95
<u>DL</u>		4,750,023	06/07/88	Shannon	357	23.3	06/05/87

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<u>DL</u>		H. Pein and James D. Plummer, "Performance of the 3-D PENCIL Flash EPROM Cell and Memory Array", IEEE Transactions on Electron Devices, Volume 42, No. 11, 1995, pp. 1982-1991.
<u>DL</u>		H. Pein and James D. Plummer, "A 3-D Sidewall Flash EPROM Cell and Memory Array", Electron Device Letters, Volume 14, (8), 1993, pps. 415-417.

EXAMINER

[Signature]

DATE CONSIDERED

4/4/05

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

ATTY DOCKET NO.
100-23700 (P05749)

SERIAL NO.
New

Peter J. Hopper et al.

FILING
Herewith

GROUP
Unknown

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>PH</i>	5,504,359	04/02/96	Rodder	257	329	01/06/95
<i>PH</i>	5,073,519	12/17/91	Rodder	437	180	10/31/90
<i>PH</i>	5,087,581	02/11/92	Rodder	437	41	10/31/90

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>PH</i>		U. Simu et al., "Limits in Micro Replication of CVD Diamond By Moulding Technique", 1997, [online], [retrieved on 2003-11-16]. Retrieved from the Internet: <URL:http://www.angstrom.uu.se/solidstatephysics/joakim/limits.pdf>. pp. 1-11, (note page 5, column 2, lines 15-23).
<i>PH</i>		E. Hui et al., "Carbonized Parylene as a Conformal Sacrificial Layer", [online], [retrieved on 2003-11-16]. Retrieved from the Internet: <URL:http://www.bsac.eecs.berkeley.edu/archive/users/hvi-elliott/pdf/sacpaper.pdf>. pp 1-5 (unnumbered), (note page 2, Process Characterization, first paragraph).

EXAMINER

PH

DATE CONSIDERED

4/4/05

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

100-23700 (P05749)

Application Number

New

Applicant(s)

Peter J. Hopper et al.

Filing Date

Herewith

Group Art Unit

Unknown

*EXAMINER
INITIAL

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

G. Stemme, "Fabrication of MEMS", [online], [retrieved on 2003-11-16], Retrieved from the Internet:
<URL:http://mmadou.eng.vci.edu/PDF%20Files/Stemme%20Fabrication.pdf>. pp. 1-9 (unnumbered), (note page 3.)

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.